

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of :  
Shoriki NARITA et al. :  
Serial No. NEW : **Attn: APPLICATION BRANCH**  
Filed August 29, 2003 : Attorney Docket No. 2003\_1226

BUMP FORMING APPARATUS FOR  
CHARGE APPEARANCE SEMICONDUCTOR  
SUBSTRATE, CHARGE REMOVAL  
METHOD FOR CHARGE APPEARANCE  
SEMICONDUCTOR SUBSTRATE,  
CHARGE REMOVING UNIT FOR  
CHARGE APPEARANCE SEMICONDUCTOR  
SUBSTRATE, AND CHARGE APPEARANCE  
SEMICONDUCTOR SUBSTRATE  
(Rule 1.53(b) Divisional  
of Serial No. 10/019,700,  
Filed January 2, 2002)

THE COMMISSIONER IS AUTHORIZED  
TO CHARGE ANY DEFICIENCY IN THE  
FEES FOR THIS PAPER TO DEPOSIT  
ACCOUNT NO. 23-0975

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**PRELIMINARY AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**Prior to initial examination, kindly amend the application as follows:**